

<b>FORM PTO-1449</b>			<b>Attorney Docket:</b> 20002.0324	<b>Application No.:</b> 10/600,770
<b>INFORMATION DISCLOSURE CITATION</b>			<b>Applicants:</b> S. Wu	<b>Examiner:</b> To Be Assigned
			<b>Filing Date:</b> June 23, 2003	<b>Group Art Unit:</b> 1714

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<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER INITIAL	REF. NO.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS
DB	AA	6,506,851 B2	1/14/03	Wu	525	415
	AB	6,476,176 B1	11/5/02	Wu	528	76
	AC	6,267,692	7/31/01	Higuchi et al.	473	365
	AD	6,231,460	5/15/01	Higuchi et al.	473	374
	AE	6,180,722 B1	1/30/01	Dalton et al.	525	193
	AF	6,180,040 B1	1/30/01	Ladd et al.	264	248
	AG	5,993,968	11/99	Umezawa	—	—
	AH	5,977,264	11/2/99	Ichikawa et al.	525	329.9
	AI	5,929,189	7/27/99	Ichikawa et al.	528	76
	AJ	5,908,699	06/01/99	Kim	428	408
	AK	5,908,358	6/1/99	Wu	473	378
	AL	5,885,172	3/23/99	Hebert et al.	473	354
	AM	5,792,008	08/11/98	Kakiuchi et al.	473	354
	AN	5,779,561	07/14/98	Sullivan et al.	473	373
	AO	5,733,428	03/31/98	Calabria et al.	264	134
	AP	5,692,974	12/02/97	Wu et al.	473	377
	AQ	5,484,870	01/16/96	Wu	528	28
	AR	5,334,673	08/02/94	Wu	273	235 R
	AS	5,006,297	4/9/91	Brown et al.	264	234
	AT	4,911,451	03/27/90	Sullivan et al.	273	235 R
	AU	4,884,814	12/05/89	Sullivan	273	235 R
	AV	4,526,375	07/02/85	Nakade	273	235 R
	AW	4,431,193	02/14/84	Nesbitt	273	235 R
	AX	4,323,247	04/06/82	Keches et al.	273	235 R
	AY	4,123,061	10/31/78	Dusbiber	273	220
	AZ	3,819,768	06/25/74	Molitor	260	897 B
	BA	3,454,280	07/08/69	Harrison et al.	273	235
	BB	3,264,272	08/02/66	Rees	260	78.5
	BC	3,147,324	09/01/64	Ward	264	254
<b>FOREIGN PATENT DOCUMENTS</b>						
	REF. NO.	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	TRANSLATION
<b>OTHER REFERENCES</b>						
	REF. NO.	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.				
DB	BD	Grant & Hackh's Chemical Dictionary 5 <sup>th</sup> Edition p. 118, Feb. 1990				
✓	BE	John A. Schey, Introduction to Manufacturing Processes 410 (Anne Duffy, ed., McGraw-Hill 2d ed. 1987) (1977).				

Examiner <i>David Beattie</i>	Date Considered <i>12/20/04</i>
Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Application	